



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*8/1/02
Cheresa
7/8/02*

Application No.: 09/710,489

Attorney Docket No.: S99-190

Filing Date: 11/10/2000

Art Unit: 2818

Applicant: Kenneth A. Honer

Examiner: David Vu

Title: **Sputtered Silicon for Microstructures and Microcavities**

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Assistant Commissioner for Patents
Washington, DC 20231

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on 6/21/02
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Jacqueline Guerro

Jacqueline Guerro
Signature

REPLY UNDER 37 C.F.R. § 1.111 (AMENDMENT A)

Box Non-Fee Amendment
Commissioner of Patents and Trademarks
Washington, DC 20231

RECEIVED
JUL - 3 2002
TECHNOLOGY CENTER 2800

Sir:

In response to the Office Action mailed on April 12, 2002, kindly amend the above-identified application as follows. A marked-up version of the replacement paragraphs showing all the changes being made is attached herewith on separate sheets. A marked-up version of the claim(s) showing all the changes being made is also attached herewith on separate sheet(s).